



Docket No.: 245402015100  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Masayasu FUTAGAWA et al.

Application No.: 10/575,187

Filed: September 29, 2004

For: VAPOR DEPOSITION METHOD AND  
VAPOR DEPOSITION APPARATUS

Confirmation No.: N/A

Group Art Unif: Not Yet Assigned

Examiner: Not Yet Assigned

**STATUS INQUIRY**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

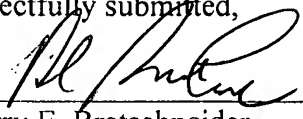
Dear Sir:

It is respectfully requested that the attorney named below be advised of the status of the above-identified application. Please advise us of when we might expect to receive a Filing Receipt from the Patent and Trademark Office.

Dated: February 23, 2007

Respectfully submitted,

By

  
Barry E. Bretschneider

Registration No.: 28,055  
MORRISON & FOERSTER LLP  
1650 Tysons Blvd, Suite 300  
McLean, Virginia 22102  
(703) 760-7743